

Interference Search p 1/2
EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1	((silicon si) and (substrate wafer bulk) and (anode) and (mask\$3 pattern\$3) and (electro\$1chemical electro\$1polish\$3) and (current adj density) and (porous adj (silicon si layer)) and (polysilicon) and (heater) and (thermocoupl\$2) and (dopant) and (aluminum al)).clm.	US-PGPUB	OR	ON	2007/01/24 11:22
L2	1	((silicon si) and (substrate wafer bulk) and (anode) and (mask\$3 pattern\$3) and (electro\$1chemical electro\$1polish\$3) and (current adj density) and (porous adj (silicon si layer)) and (heater) and (thermocoupl\$2)).clm.	US-PGPUB	OR	ON	2007/01/24 11:19
L3	1	((silicon si) and (substrate wafer bulk) and (anode) and (mask\$3 pattern\$3) and (electro\$1chemical electro\$1polish\$3) and (current adj density) and (porous adj (silicon si layer))).clm.	US-PGPUB	OR	ON	2007/01/24 11:19
L4	7	((silicon si) and (substrate wafer bulk) and (electro\$1chemical electro\$1polish\$3) and (current adj density) and (porous adj (silicon si layer))).clm.	US-PGPUB	OR	ON	2007/01/24 11:21
L5	1	((micro\$1channel micro\$1fluidic (micro adj (channel fluidic))) and (electro\$1chemical electro\$1polish\$3) and (current adj density) and (porous adj (silicon si layer))).clm.	US-PGPUB	OR	ON	2007/01/24 11:22
L6	1	((micro\$1channel micro\$1fluidic (micro adj (channel fluidic))) and (anode cathode electrode) and (heater) and (thermocouple\$2) and (aluminum al) and (porous adj (silicon si layer))).clm.	US-PGPUB	OR	ON	2007/01/24 11:23
L7	1	((micro\$1channel micro\$1fluidic (micro adj (channel fluidic))) and (heater) and (thermocouple\$2) and (aluminum al) and (porous adj (silicon si layer))).clm.	US-PGPUB	OR	ON	2007/01/24 11:23
L8	1	((micro\$1channel micro\$1fluidic (micro adj (channel fluidic))) and (heater) and (thermocouple\$2) and (porous adj (silicon si layer))).clm.	US-PGPUB	OR	ON	2007/01/24 11:23

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L9	1	((micro\$1channel micro\$1fluidic (micro adj (channel fluidic))) and (thermocouple\$2) and (porous adj (silicon si layer))).clm.	US-PGPUB	OR	ON	2007/01/24 11:24
L10	14	((micro\$1channel micro\$1fluidic (micro adj (channel fluidic))) and (porous adj (silicon si layer))).clm.	US-PGPUB	OR	ON	2007/01/24 11:24

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Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	23	(250/338.4 438/54 257/467).cccls. and (porous same (silicon si))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/24 10:54
S2	0	("2005/0072926").URPN.	USPAT	OR	ON	2007/01/24 10:48
S3	2	((ANDROULA) near2 (NASSIOPOULOU)).INV.	US-PGPUB; USPAT; USOCR	OR	ON	2007/01/24 10:48
S4	1	((GRIGORIS) near2 (KALTSAS)). INV.	US-PGPUB; USPAT; USOCR	OR	ON	2007/01/24 10:48
S5	1	((DIMITRIOS) near2 (PAGONIS)). INV.	US-PGPUB; USPAT; USOCR	OR	ON	2007/01/24 10:50
S6	6	("5565084" "6139758" "6359276" "6759265" "6803637" "6832523"). PN.	US-PGPUB; USPAT; USOCR	OR	ON	2007/01/24 10:50
S7	24336	((microfluidic micro-fluidic fluidic micro) adj channel) or microchannel or micro-channel	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/24 10:55
S8	19525	porous with silicon	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/24 10:55
S9	106	S7 same S8	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/24 10:56
S10	20	((porous adj silicon) same (cavity gap)) and (thermal detector sensor thermoelectric) and @pd>="20061011"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/24 10:59

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S11	3	((porous adj silicon) and (current adj density) same electropolish\$3) and @pd>="20061011"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/24 10:59
S12	0	((porous with (silicon si)) same S7) not S9	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/24 10:58
S13	250	(porous with (silicon si)) and ("438" "257" "250").clas. and @pd>="20061011"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/24 10:59